

Serial No. 10/502,465

Atty. Docket 30848/40323

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Serial No. : 10/502,465
Confirmation : 3973

Applicants : Nassiopoulou et al.
371 (c) date : July 23, 2004

Title: LOW POWER SILICON
THERMAL SENSORS AND
MICROFLUIDIC DEVICES BASED ON
THE USE OF POROUS SEALED AIR
CAVITY TECHNOLOGY OR
MICROCHANNEL TECHNOLOGY

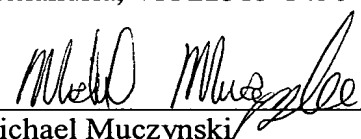
Art Unit : 2878
Examiner : ROSENBERGER,
Frederick F.

Atty Docket : 30848/40323
Customer No. : 04743

) Date of Deposit:
) November 17, 2005
)

) I hereby certify that this paper and the
) documents referred to therein are being
) deposited with the United States Postal Service
) with sufficient postage, as first class mail, in an
) envelope addressed to:

) Mail Stop Amendment
) Commissioner for Patents
) P.O. Box 1450
) Alexandria, VA 22313-1450
)

) 
) Michael Muczynski

AMENDMENT "A"

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir: ,

Please amend this application as specified on the following pages.

11/22/2005 FFANAEIA 00000092 10502465

01 FC:2253

510.00 OP